

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Robert Z. Bachrach, et al.

Serial No.: 10/675,031

Filed: September 30, 2003

Title: METHOD AND APPARATUS FOR
CHEMICAL-MECHANICAL JET ETCHING
OF SEMICONDUCTOR STRUCTURES

§ Group Art Unit: 1765

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§ Examiner: Kin Chan Chen

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§ Docket No.:
§ AM-5609.D1 (1630-110)
§

Date: October 21, 2005

PETITION FOR EXTENSION OF TIME

Mail Stop Amendment
Commissioner for Patents
P. O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

1. This is a petition for a one-month extension of the time to file a response to the Office Action mailed June 21, 2005 in the subject patent application. The due date for the response was September 21, 2005, and the present one-month extension of time will provide for a response through October 21, 2005.

10/25/2005 HLE333 00000076 502635 10675031

01 FC:1251 120.00 DA

CERTIFICATE OF MAILING UNDER 37 CFR § 1.10

I hereby certify that this paper is being deposited with the U.S. Postal Service on the date shown below with sufficient postage as U.S. Express Mail No. EV 095247069 US in an envelope addressed to the: Mail Stop Amendment, Commissioner for Patents, P. O. Box 1450, Alexandria, VA 22313-1450.


Date: October 21, 2005


Shirley L. Church, Reg. No. 31,858

2.	Extension:	<u>Length of Extension</u>	<u>Fee Under 37 CFR § 1.17</u>
		<u>X</u> One-Month	\$ 120.00
		___ Two-Month	\$ 450.00
		___ Three-Month	\$ 1,020.00
		___ Four-Month	\$ 1,590.00
		___ Fifth-Month	\$ 2,160.00

3. The Commissioner is hereby authorized to charge the \$120.00 extension fee, and any additional fees that may be due, and/or credit any overpayment to Deposit Account No. 50-2635, Duckor Spradling Metzger & Wynne, of 401 West A Street, Suite 2400, San Diego, CA 92101-7915.

Respectfully Submitted,



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